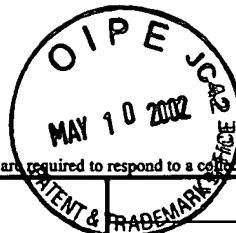


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Substitute for form 1449A/PTO		INFORMATION DISCLOSURE STATEMENT BY APPLICANT (use as many sheets as necessary)		Complete if Known	
Application Number		09/904,906			
Filing Date		07/16/2001			
First Named Inventor		Takeshi FUKADA et al.			
Group Art Unit		2825			
Examiner Name		Unassigned			
Sheet	1	of	1	Attorney Docket Number	0756-2332

U.S. PATENT DOCUMENTS						
Examiner Initials ¹	Cite No. ¹	U.S. Patent Document		Name of Patentee or Applicant of Cited Document	Date of Publication of Cited Document MM-DD-YYYY	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
		Number	Kind Code ² (if known)			
ABM		5,069,531		Yamazaki et al.	12/03/91	
ABM		5,109,292		Yamazaki	04/28/92	

FOREIGN PATENT DOCUMENTS							
Examiner Initials ¹	Cite No. ¹	Foreign Patent Document			Name of Patentee or Applicant of Cited Document	Date of Publication of Cited Document MM-DD-YYYY	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
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ABM		JP	62-112128		Yamazaki	05/23/87	Abst
ABM		EP	0 225 470	AZ	Yamazaki	06/16/87	Eng

OTHER PRIOR ART - NON PATENT LITERATURE DOCUMENTS				
Examiner Initials ¹	Cite No. ¹	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.		
ABM		T. Hanada et al, "Preparation and Physical Properties of RF-Sputtered Amorphous Films in the Al ₂ O ₃ -AlN System," Journal of Non-Crystalline Solids 135 (1991), pp. 227-235		

Examiner Signature	<i>ABM</i>	Date Considered	1-12-2003
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¹ Unique citation designation number. ² See attached Kinds of U.S. Patent Documents. ³ Enter Office that issued the document, by the two-letter code (WIPO Standard ST.3). ⁴ For Japanese patent documents, the indication of the year of the reign of the Emperor must precede the serial number of the patent document. ⁵ Kind of document by the appropriate symbols as indicated on the document under WIPO Standard ST.16 if possible. ⁶ Applicant is to place a check mark here if English language Translation is attached.

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